



In re Application of:

Kim, et al.

Application No.:

10/632,873

Filing Date:

August 1, 2003

Title:

SELECTIVE ETCHING OF CARBON-
DOPED LOW-K DIELECTRICS

Direct to:

Mail Stop Reconsideration
Commissioner for Patents
United States Patent and Trademark Office
Alexandria, VA 22313-1450

NOTICE UNDER 37 C.F.R. §1.251 – PENDING APPLICATION

Statement (check the appropriate box):

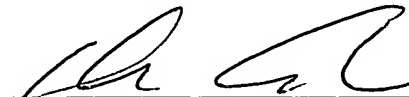
☒ The copy submitted with this reply is a complete and accurate copy of Applicant's record of all of the correspondence between the Office and the Applicant for the above-identified application (except for U.S. patent documents), and Applicant is not aware of any correspondence between the Office and Applicant for the above-identified application that is not along Applicant's records.

☐ The copy of the paper(s) listed in the notice under 37 C.F.R. §1.251 is/are a complete and accurate copy of Applicant's record of such paper(s).

☐ The papers produced by Applicant are Applicant's complete record of all of the correspondence between the Office and the Applicant for the above-identified application (except for U.S. patent documents), and Applicant is not aware of any correspondence between the Office and the Applicant for the above-identified application that is not among Applicant's records.

☐ Applicant does not possess any record of the correspondence between the Office and the Applicant for the above-identified application.

Sept. 27, 2004
Date


Signature

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A copy of this notice should be returned with the reply.